

Transaction Information

| | |
|---------------------|------------------|
| Tool ID | OPI922 |
| Tool Status | Connected |
| Location | Dresden, Germany |
| Wafer Size | 300 mm |
| Fab Section | Defect Detection |
| Tool Available Date | 2025-02-01 |

General Product Information

| | |
|-------------------|-----------------------|
| Vendor Supplier | HSEB |
| Model | MMT 300 |
| Vintage | 2007 |
| Serial No | 004/01 (2007) |
| Asset Description | OPI922-T MMT 300 |
| Software Version | 4.32.4/10.1.04 |
| CIM | SECS/GEM |
| Process | Wafer Inspection Tool |

Hardware Configuration (Fab)

| System Type | Description | Quantity | Status |
|----------------|--------------------|----------|--------|
| Main System | microscope station | 1 | OK |
| Options System | | | |

Hardware Configuration (Subfab / Auxilliary Units)

| Description | Quantity | Status |
|-------------|----------|--------|
| NONE | | |

Missing/Faulty Parts / Accesories List

| Description | Quantity |
|-------------|----------|
| NONE | |

Tool Pictures

General

mainframe and inspection module



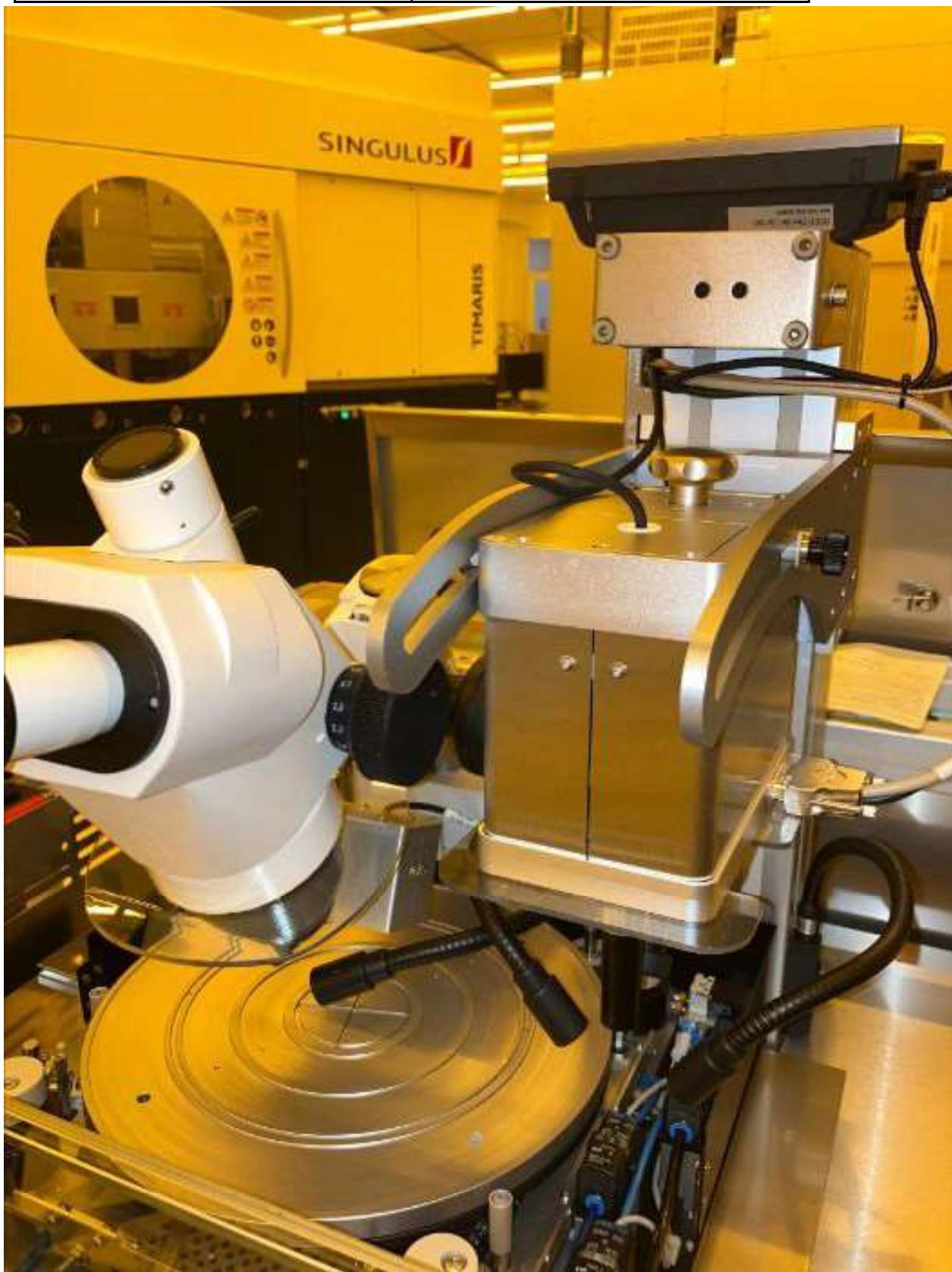
General

mainframe and inspection module



General

mainframe and inspection module



General

mainframe and inspection module



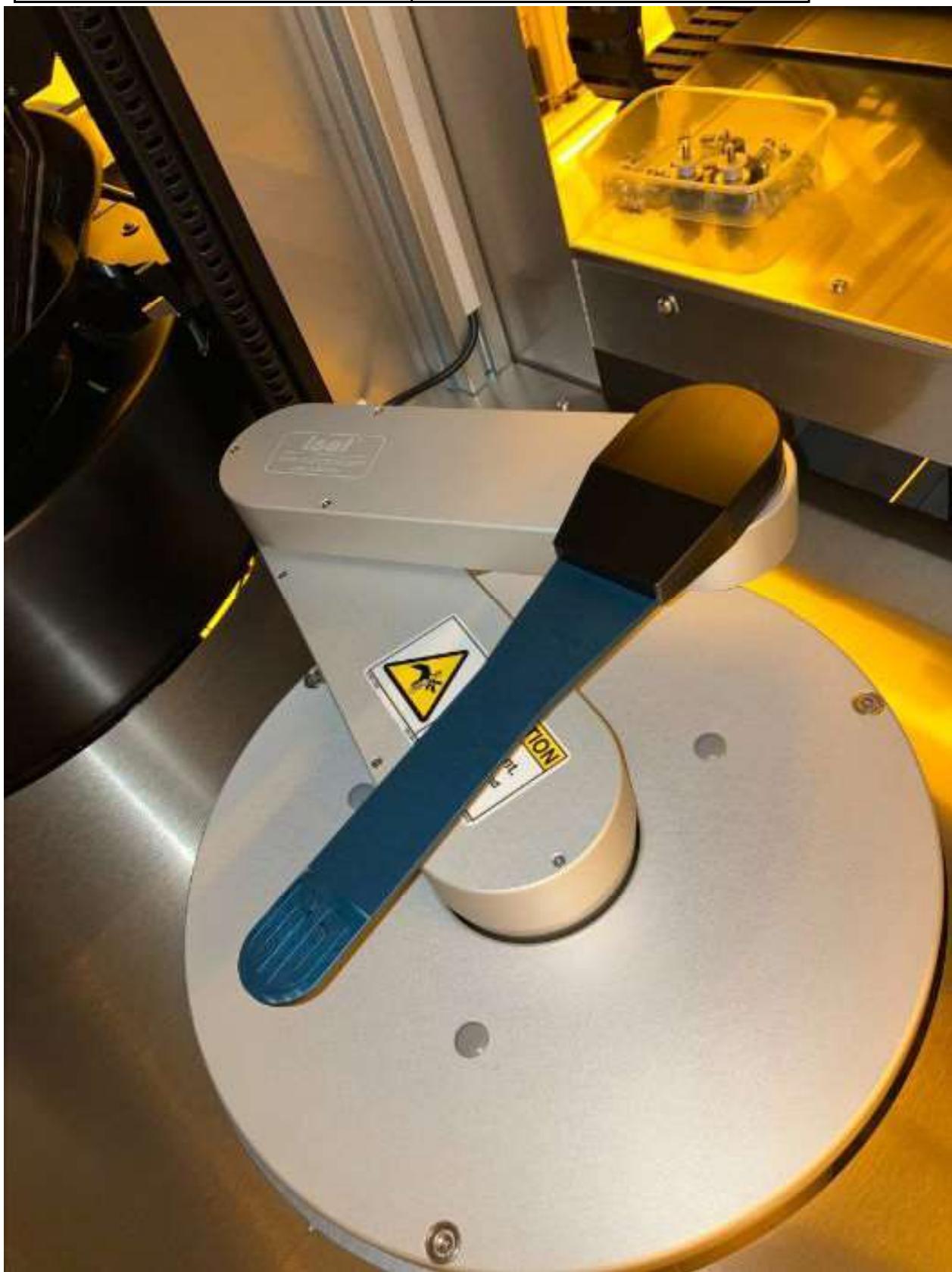
General

mainframe and inspection module



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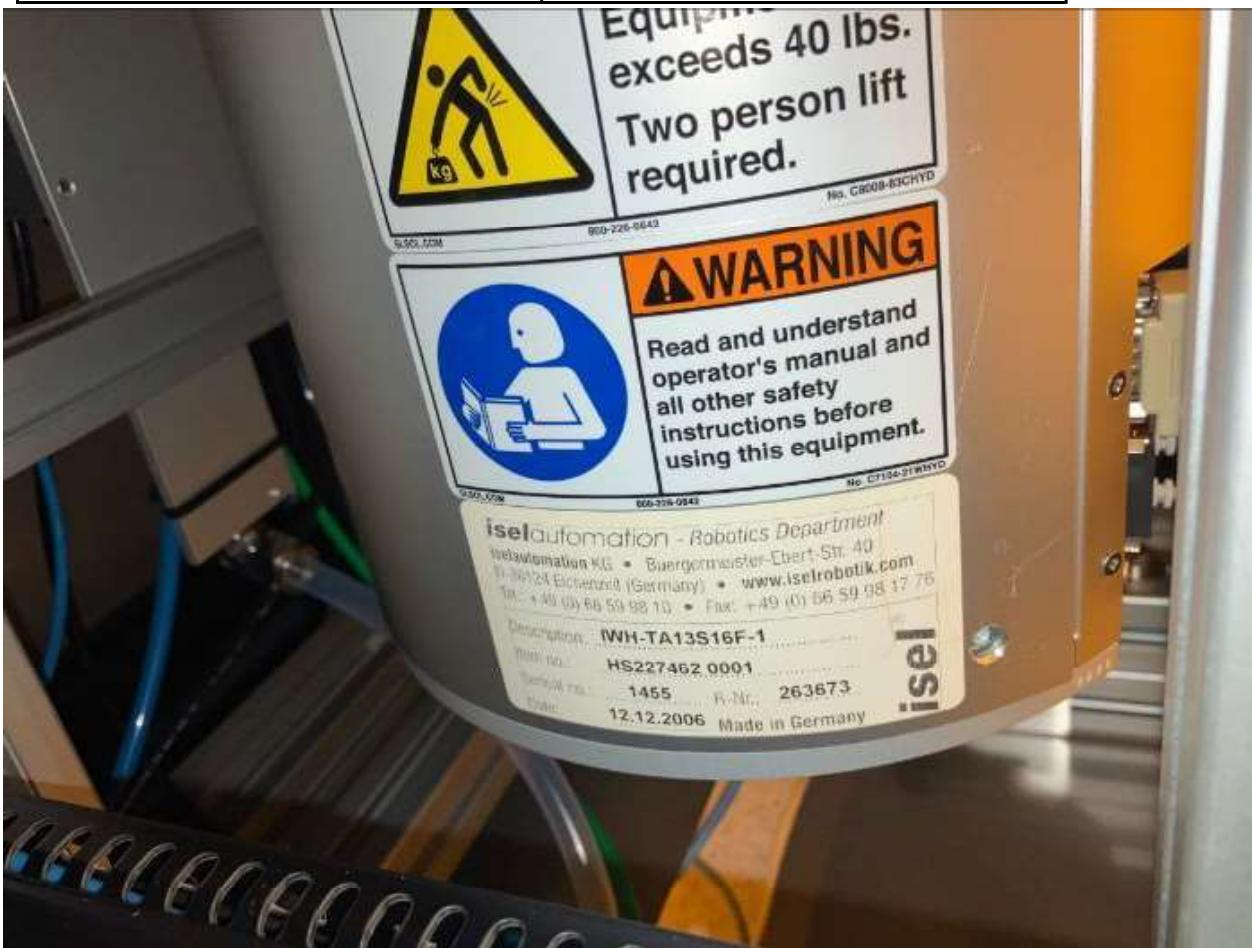
General

mainframe and inspection module



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Manufacture Serial

Serial Number Plate

